# Background

Data Analytics is a very crucial component for robust performance of any Semiconductor Fabrication Industry. And Semiconductor Laboratory (SCL) is no different in this regard. Better Data Analytics would help in pre-determining of any faulty equipment part by visualizing at the parameter(s)’ drifts in process charts.

This document illustrates the Data Analytics on “**Average Product Lot yield with Device’s Effective Area”** for year-2020.

The data visualization chart:

* shows the trend of ‘Lot Yield’ with Device’s Effective Area
* shows the yield of lot ids for any ‘Device’ like Vikram 1601, etc.., independently.
* visualizes the zone where device(s) has maximum ‘Lot Yield’.
* features interactiveness (zoom-in/out, hover, 360° rotation) with portability (in .html format) via mails, etc…

# Analytics

Data Analytics is comprised of 3 main modules:

1. Data Acquisition:

* The data is available in form of excel file (in .xlsx format).
* Each device has min. 1 lot ID.
* There are total **40** device names.
* The effective area varies from **0.89 mm2** to **203.08 mm2**.



Fig. Data of Avg. Product Yield with Effective Area in Excel format

* For this, the coding script is:

1. Data Wrangling

* This module is for cleansing of acquired data and converts it as palette for data visualization.
* It converts the acquired data into “structured & filtered” format.

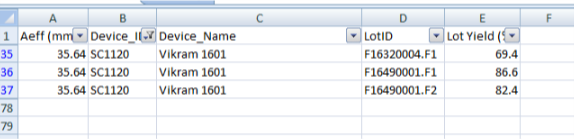


Fig. Filtered Excel data e.g. ‘Vikram 1601’ device

1. Data Visualization

# Inference

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* Fab-out dates can be added in one of the axes in charts. This would give the information about *“whether the lot\_id (pointed at) is recent or not in terms of Fab-out”*.

# Appendix

# Disclaimer

TODO

* Add no.s to the figures